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Our File No. <u>9281-4140</u> Client Reference No. CK US00016

PATENT APPLICATION TRANSMITTAL LETTER

To the	Comm	nissioner	for	Patents
10 1110	COLLIII	1133101161	101	ratems

Transmitted herewith for filing is the patent application of Akira Nakano and Tadahiro Ohmi for Plasma Processing Apparatus and System, Performance Validation System and Inspection Method Therefor.												
Enclo	nclosed are:											
	Prelim	Preliminary Amendment with attached Appendix A										
	<u>196</u> pa followi	g pages of application (including title page), <u>37</u> sheets of formal drawings and the owing Appendices: <u>n/a</u>										
X	Declaration and Power of Attorney for Patent Application Assignment transmittal letter and Assignment of the invention to: Alps Electric Co Tadahiro Ohmi											
	Submission of Certified Copies of Priority Documents and certified copies of Japanese Application Nos. 2000-245347 and 2000-289488											
	Information Disclosure Statement, PTO-1449, and reference <u>A1</u>											
	Other Than Small Entity Small Entity Small Entity											
For Basic F	ee	No. Filed	No. Extra	Rate	Fee \$ 355	or or	Rate	Fee \$ 710				
Total Claims 62-20 42			42	x\$9=	\$	or	x\$18=	\$756				
Indep. Claims 7-3 4 Multiple Dependent Claims Present				x\$40= +\$135=	\$	or	x\$80=	\$560]			
*If the d	Multiple Dependent Claims Present +\$135= \$ or +\$270= \$ *If the difference in col. 1 is less than zero,							\dashv				
enter "0" in col. 2.				Total	\$		Total	\$2,026				
				23-1925 in the amor		A du	plicate copy of this	s sheet is enclos	ed.			
				over the filing fee is								
	The Commissioner is hereby authorized to charge payment of the following fees associated with this credit any overpayment to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.											
		Any additional filing fees required under 37 CFR § 1.16.										
		Any patent application processing fees under 37 CFR §1.17.										
	The Com credit any	he Commissioner is hereby authorized to charge payment of the following fees during the pendency of this application or redit any overpayment to Deposit Account No. 23-1925. A duplicate copy of this sheet is enclosed.										
	Any filing fees under 37 CFR § 1.16 for presentation of extra claims.											
		Any patent application processing fees under 37 CFR § 7.17.										
, was		The issue fee s § 1,311(b). \$ \begin{aligned} \eta \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \	set in 37 CFR § 1	.18 at or before ma	iling of the Noti	ce of	<u>Allewance</u> pursua	ant to 37 CFR				

Date

Gustavo Siller, Jr.
BRINKS HOFER GILSON & LIONE
Registration No. 32,305

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE APPLICATION FOR UNITED STATES LETTERS PATENT

INVENTORS:

Akira Nakano

Tadahiro Ohmi

TITLE:

Plasma Processing Apparatus and

System, Performance Validation System and Inspection Method

Therefor

ATTORNEY:

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EXPRESS MAIL NO. EL 746 760 452 US

DATE OF MAILING 8/9/01